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		Number	Kind Code ² (# known)			
		6,377,438	B1	Deane et al.	04-23-2002	
		6,374,008	B2	Solgaard et al.	04-16-2002	
		6,360,036	B1	Couillard	03-19-2002	
		6,329,738	B1	Hung et al.	12-11-2001	
		6,307,663	B1	Kowars	10-23-2001	
		6,289,145	B1	Solgaard et al.	09-11-2001	
		6,275,325	B1	Sinclair	08-14-2001	
		6,275,320	B1	Dhuler et al.	08-14-2001	
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		6,211,598	B1	Dhuler et al.	04-03-2001	
		6,137,206	B1	Hill	10-24-2000	
		6,067,797	B1	Silverbrook	05-30-2000	
		5,905,571	B1	Butler et al.	05-18-1999	
		5,561,558	B1	Shiono et al.	10-01-1996	
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		6,428,173		Dhuler et al	8/6/02	
		6,329,738		Hung et al	12/11/01	

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		First Named Inventor	Chen et al
		Group Art Unit	
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Sheet 3 of 6	Attorney Docket Number	100202586-5	

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		V. RAMACHANDRAN et al., An assessment of the blazed grating electro-optic deflector, J. Phys. D: Appl. Phys. Vol. 8, 1975 pp. 1923-1926	
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		P. PHILIPPE et al., Wavelength demultiplexer: using echelette gratings on silicon substrate, Applied Optics, Vol. 24 No. 7, April 1, 1985 pp. 1006-1011	
		S. R. MALLINSON et al., Miniature micromachined Fabry-Perot interferometers in silicon, Electronics Letters, Vol. 23 No. 20, Sept. 24, 1987, pp. 1041-1043	
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
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		O. SOLGAARD et al., Deformable Grating Optical Modulator, Optics Letters, Vol. 17, No. 9, May 1, 1992, pp. 688-690	
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		D. M. BURNS et al., Development of microelectromechanical variable blaze gratings, Sensors and Actuators A:Physical, Vol. 64 No. 1, 1998, pp. 7-15	
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